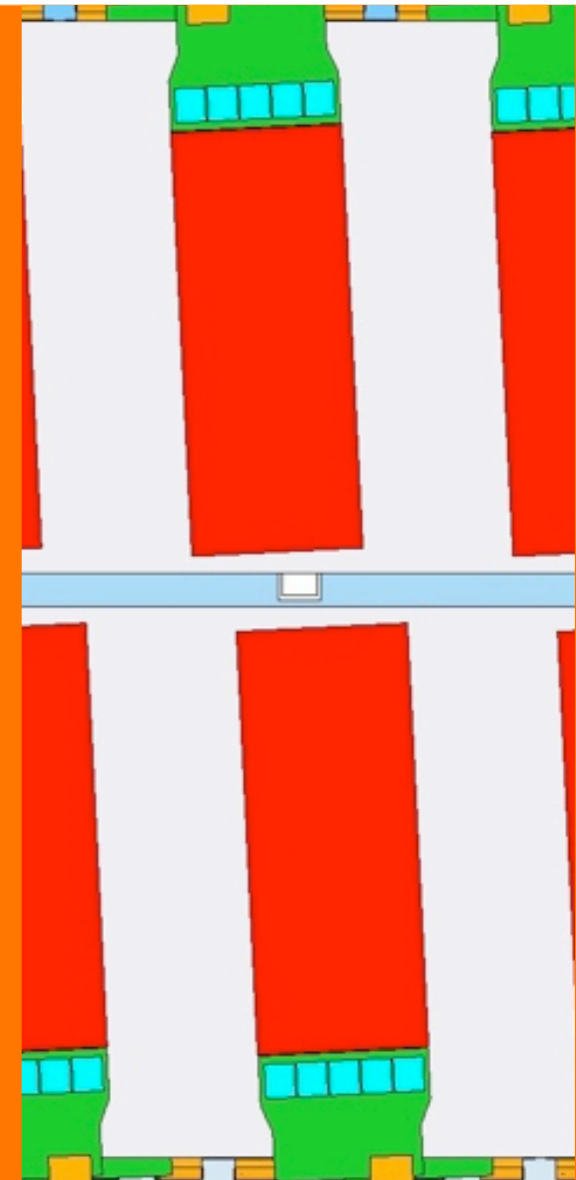


# HPS Tracking and Vertexing System



**Tim Nelson - SLAC**

Boson 2010, JLab

September 20, 2010



# The Elevator Pitch

## Our sensitivity relies upon abilities to *precisely*...

- ✦ determine invariant mass of  $A'$  decay products (estimate momentum vectors)
- ✦ distinguish  $A'$  decay vertexes as non-prompt (extrapolate tracks to origin)

Placement of a tracking and vertexing system immediately downstream from a target and inside an analyzing magnet provides both measurements with high acceptance from a single, relatively compact detector.



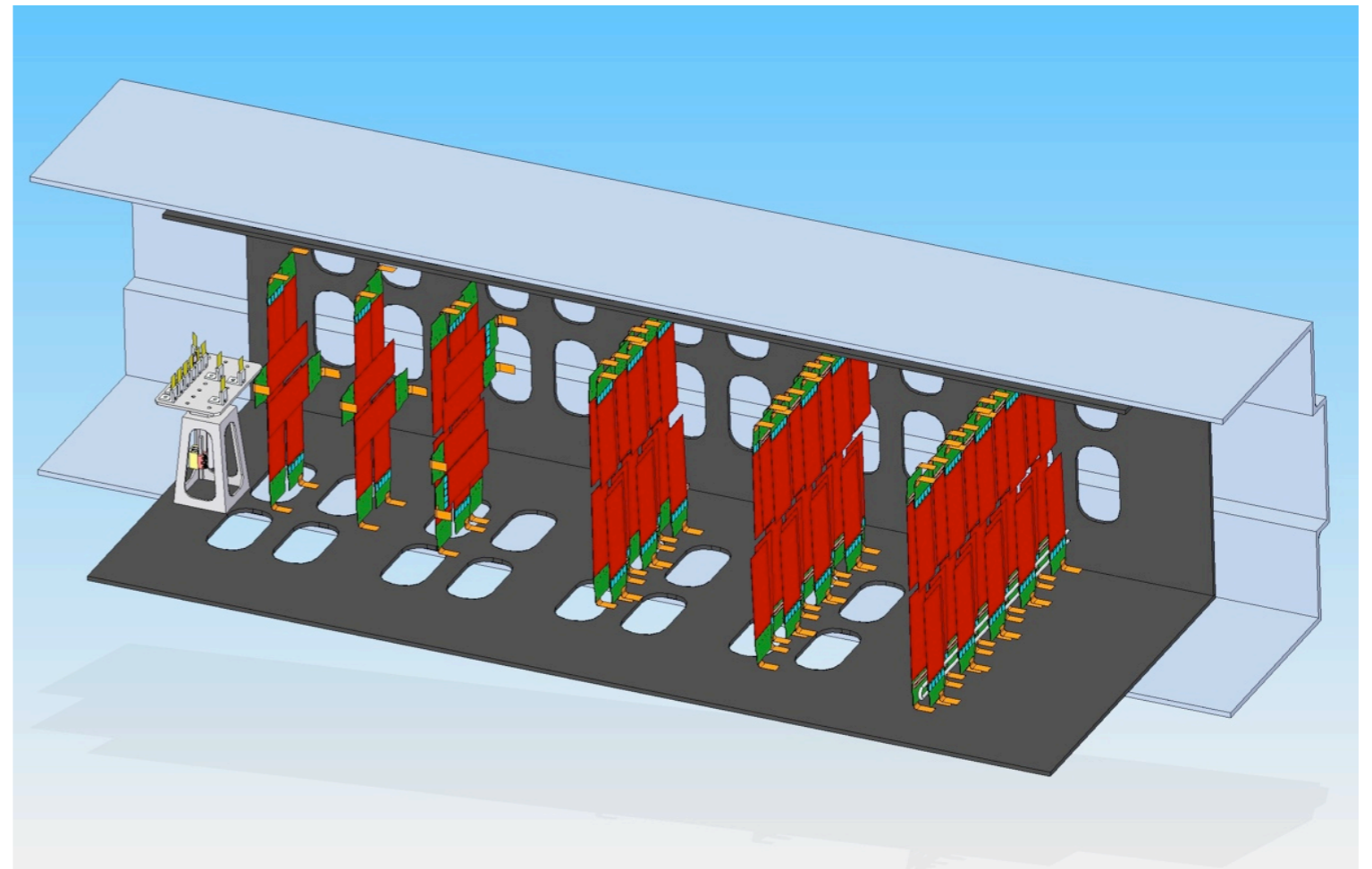
*"If they don't like our proposal I'll show them the kittens. Everybody likes kittens."*

# Challenges

- ❖ At relevant beam energies and interesting  $A'$  masses, decay products tend to be electrons with momenta order a few GeV. Multiple scattering...
  - ❖ dominates both mass and vertexing measurement errors
  - ❖ leads to pattern recognition mistakes in dense environments
- ❖ Proximity to target means primary beam must pass through apparatus.
  - ❖ scattered beam sweeps out a “dead zone” of extreme occupancy and radiation, compounded by beam-gas interactions
  - ❖ puts low-mass acceptance in opposition to longevity and tracking purity
- ❖ Long-lived  $A'$  signal very small: vertexing must be exceedingly pure to eliminate fakes.
- ❖ Most attractive if can be done quickly and at minimal cost.

# Challenges ⇒ Design Principles

- ⬢ Mass and vertex resolution
  - ⬢ low-mass construction
- ⬢ Occupancies and radiation
  - ⬢ fast, robust sensors / readout
  - ⬢ movability / replaceability
  - ⬢ operation in vacuum
- ⬢ Acceptance/Purity
  - ⬢ optimized sensor layout
- ⬢ Schedule/Budget Sensitivity
  - ⬢ reuse and recycle components and techniques





# It's *easier* being green!

silicon sensors

readout ASICs

hybrids

support and cooling

vacuum chamber



# Silicon Sensors

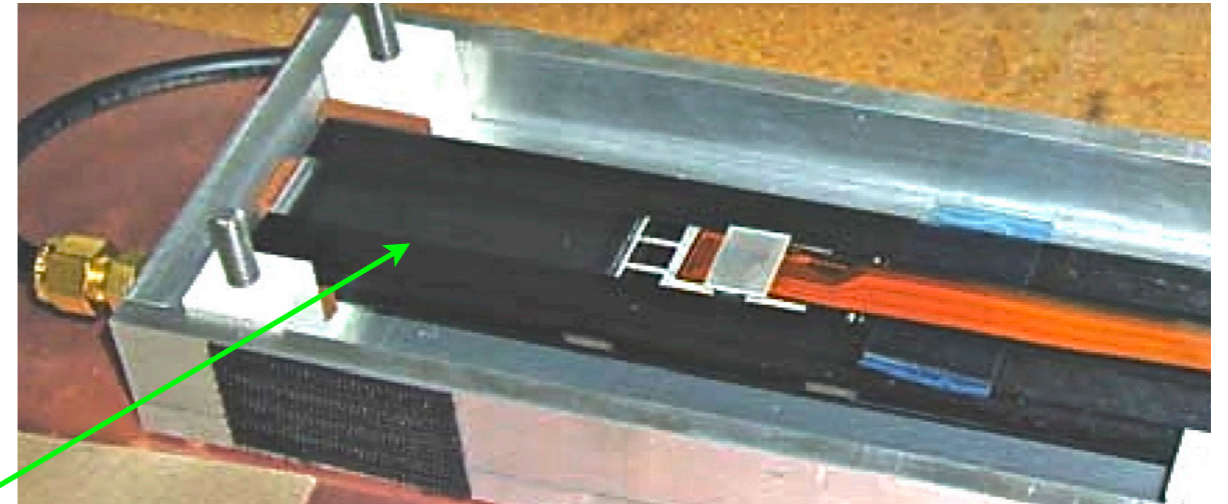
❏ pixels too massive, costly, complex:  
microstrips are the simple,  
lightweight solution

❏ Production Tevatron RunIIb sensors

❏ Radiation tolerant:  
many capable of 1000V bias

❏ Fine readout granularity

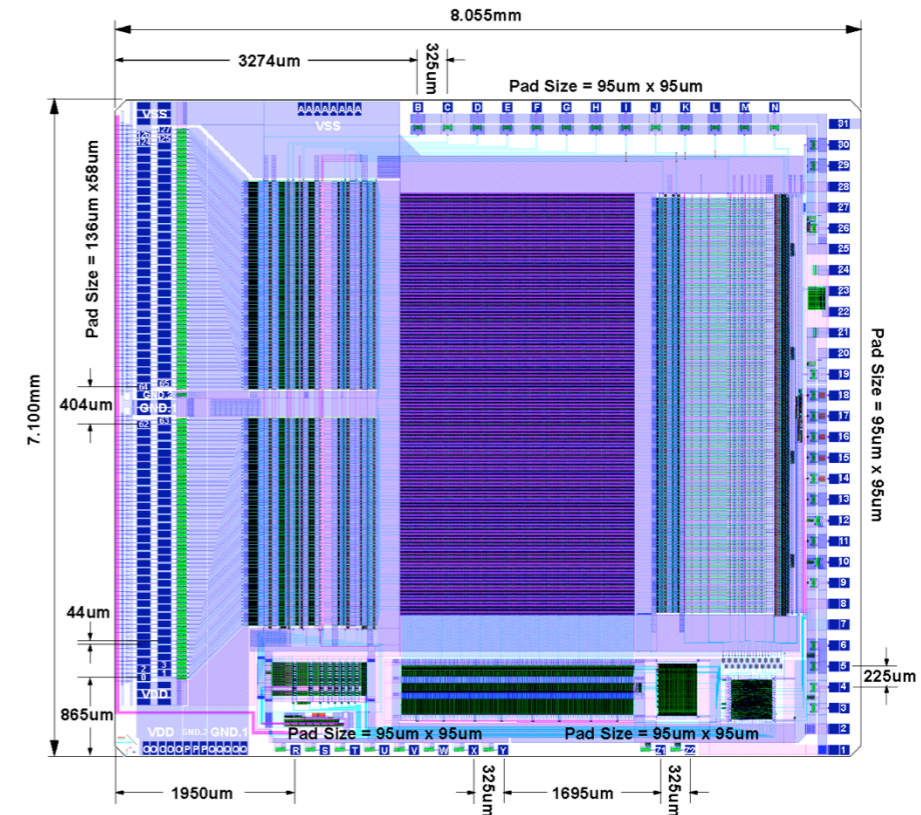
❏ Readily available in sufficient quantity



Cut Dimensions (L×W)	100 mm × 40.34mm
Active Area (L×W)	98.33 mm × 38.34mm
Readout (Sense) Pitch	60μm (30μm)
# Readout (Sense) Strips	639 (1277)
Depletion Voltage	40V < V <sub>dep</sub> < 300V
Breakdown Voltage	>350V
Total Detector Current at 350V bias	<16 μA
Bias Resistor Value (both ends of strips)	0.8 ± 0.3 MΩ
AC Coupling Capacitance	>12 pF/cm
Total Interstrip Capacitance	<1.2 pF/cm
Defective Channels	<1%

# Readout Electronics: APV25

- ⬢ Silicon readout for high rate environment: **LHC**
- ⬢ APV25 (CMS) is best of these for us.
  - ⬢ Low noise:  $S/N \approx 34$  with our sensors
  - ⬢ Radiation tolerant
  - ⬢ Chips, DAQ infrastructure, knowledge; all widely available
  - ⬢ ***Flexible in operation...***



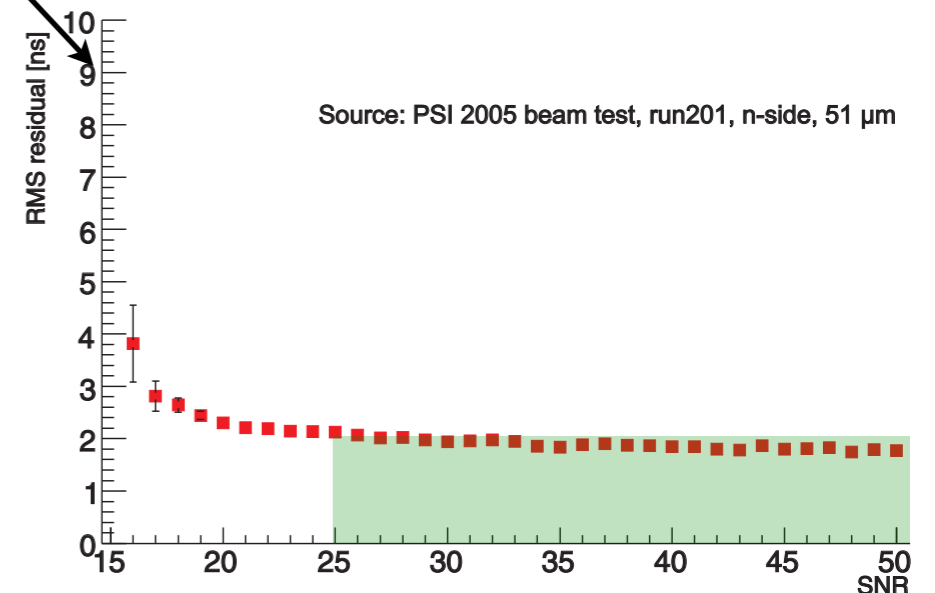
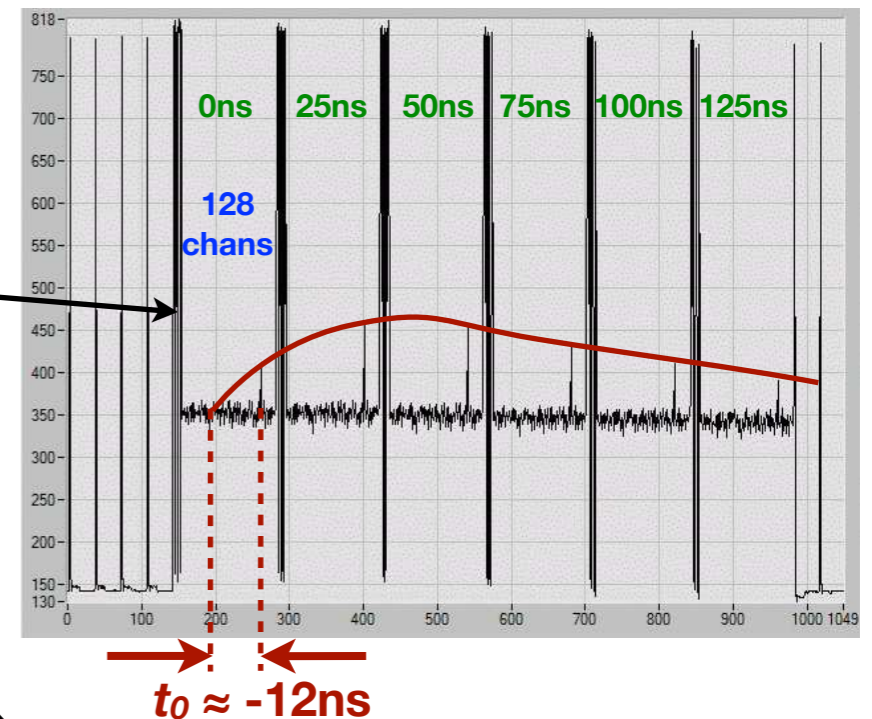
# Readout Channels	128
Input Pitch	44 $\mu\text{m}$
Shaping Time	50ns nominal (35ns min.)
Output Format	multiplexed analog
Noise Performance (multi-peak mode)	$270+36 \times C(\text{pF}) e^- \text{ ENC}$
Power Consumption	345 mW
Communication Protocol	I <sup>2</sup> C



# Timing Information

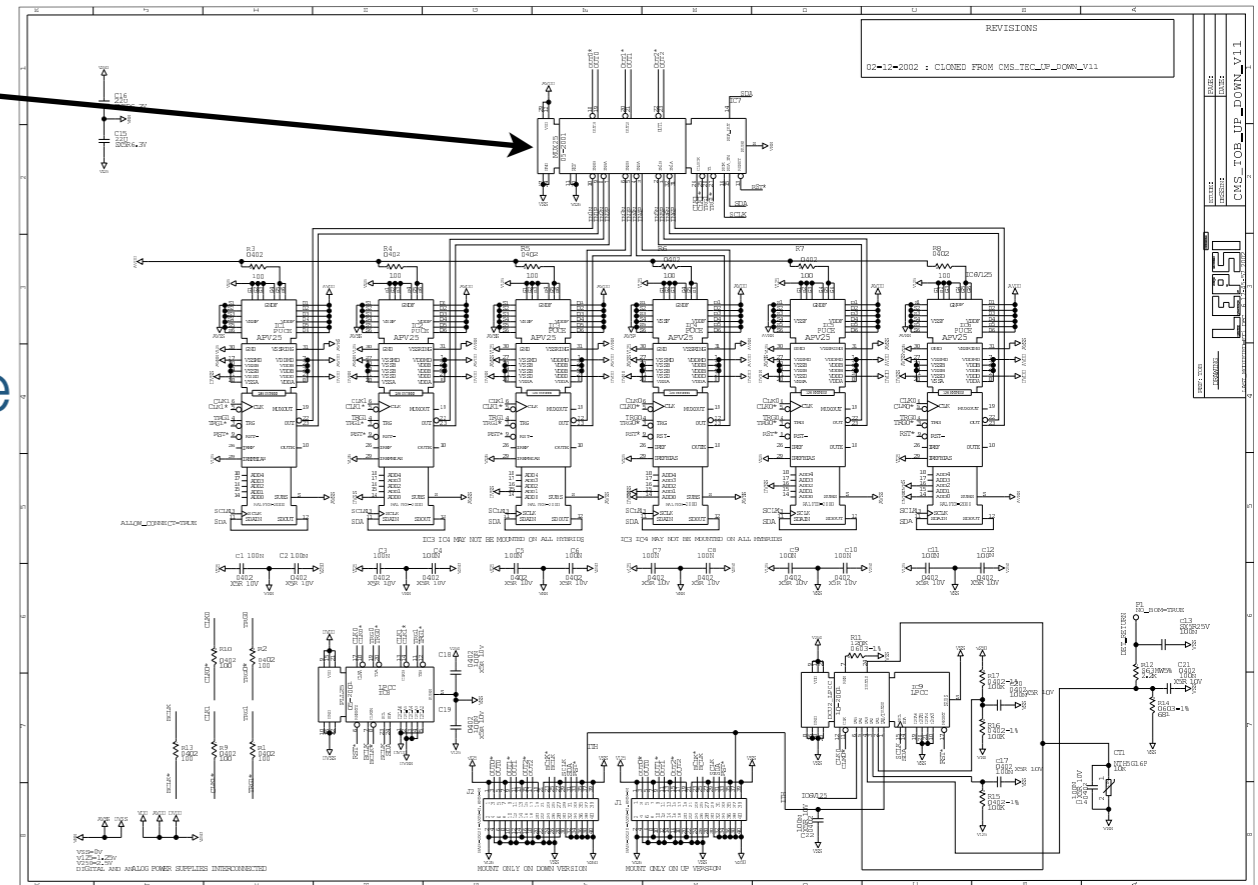
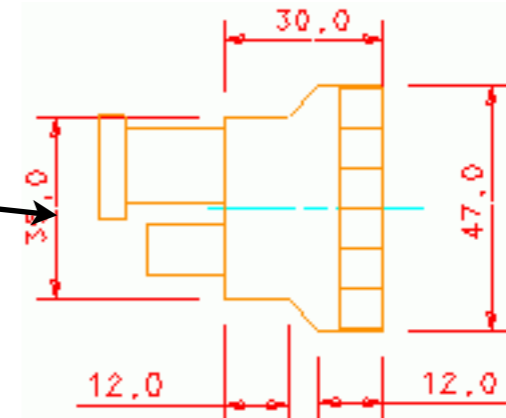
## Multi-peak readout mode offers major reduction in background occupancy:

- ⬢ Sample shaper output periodically after trigger to extract  $t_0$ : pioneered for Belle II.
  - ⬢ Fit to shaping curve determines hit time with RMS of  $\sim 2$  ns or better for  $S/N > 25$ .
  - ⬢ 6-sample readout helps at high occupancy: de-convolute two hits in same shaping window
  - ⬢ For simulation studies, simply assume a 7.5ns time window for hits when tracking ( $\sim 2\sigma$  cut).
- ➡ Fitting tracks simultaneously in space *and* time will improve on this.



# Hybrids

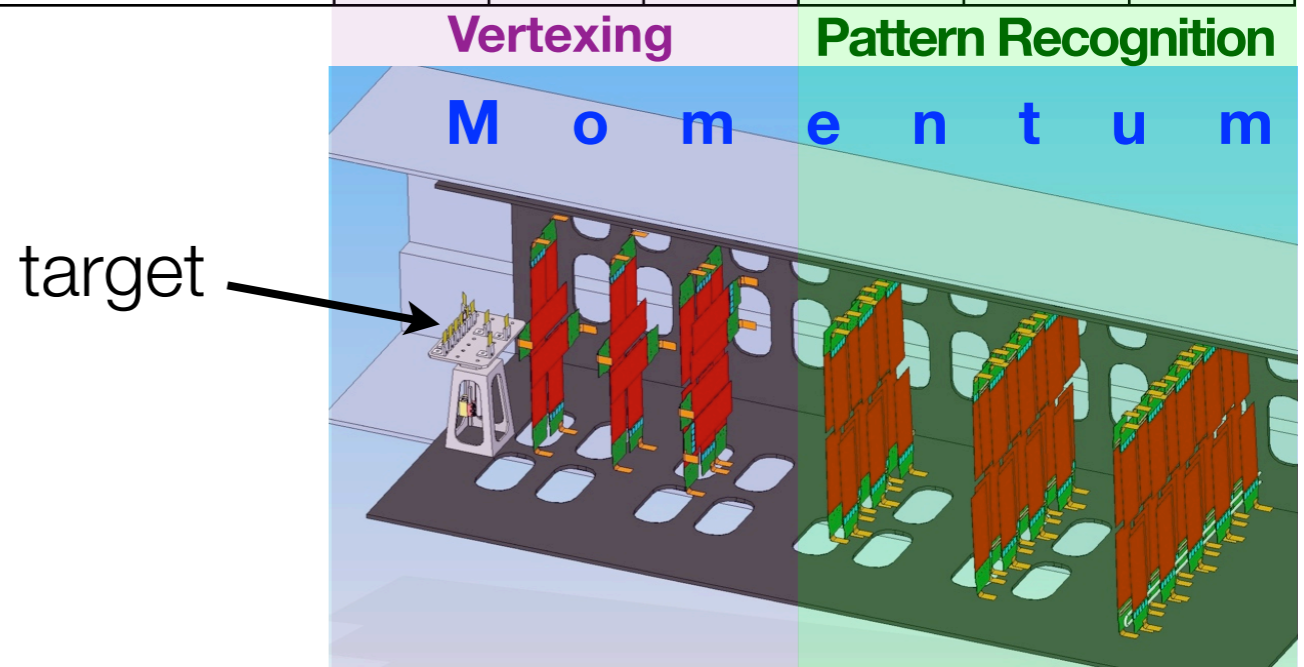
- ❏ Need something simple and compact: similar to CMS TIB hybrid, *but...*
- ❏ 5 chips instead of 6 to match sensors
- ❏ analog driver instead of APVMUX
- ❏ *probably* no need for pitch adapter
- ❏ *probably* no need for ceramic substrate
- ❏ Starting from CMS schematics, should be fairly simple
- ❏ Want prototype soon: **critical path.**



# Detector Layout

- Layers 1-3: vertexing
- Layers 4-6: pattern recognition with adequate pointing into Layer 2.
- Bend plane measurement in all layers: momentum
- 106 sensors/hybrids
- 530 APV25 chips
- 67840 channels

	Layer 1	Layer 2	Layer 3	Layer 4	Layer 5	Layer 6
<b>z position, from target (cm)</b>	10	20	30	50	70	90
<b>Stereo Angle</b>	90 deg.	90 deg.	90 deg.	50 mrad	50 mrad	50 mrad
<b>Bend Plane Resolution (<math>\mu\text{m}</math>)</b>	$\approx 6$	$\approx 6$	$\approx 6$	$\approx 6$	$\approx 6$	$\approx 6$
<b>Stereo Resolution (<math>\mu\text{m}</math>)</b>	$\approx 6$	$\approx 6$	$\approx 6$	$\approx 120$	$\approx 120$	$\approx 120$
<b># Bend Plane Sensors</b>	4	4	6	10	14	18
<b># Stereo Sensors</b>	2	2	4	10	14	18
<b>Dead Zone (mm)</b>	$\pm 1.5$	$\pm 3.0$	$\pm 4.5$	$\pm 7.5$	$\pm 10.5$	$\pm 13.5$
<b>Power Consumption (W)</b>	10.5	10.5	17.5	35	49	63

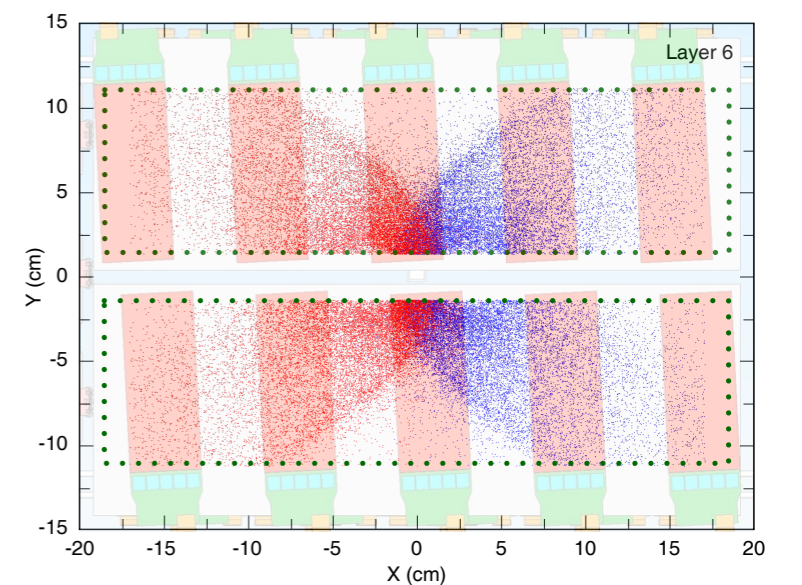
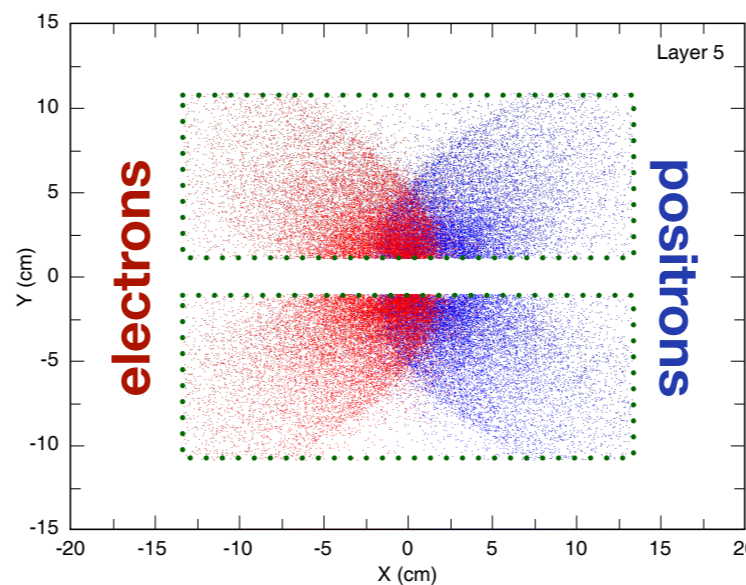
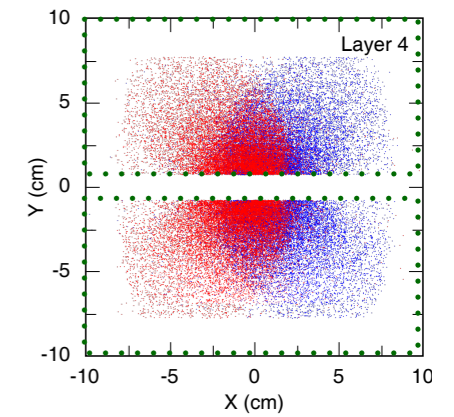
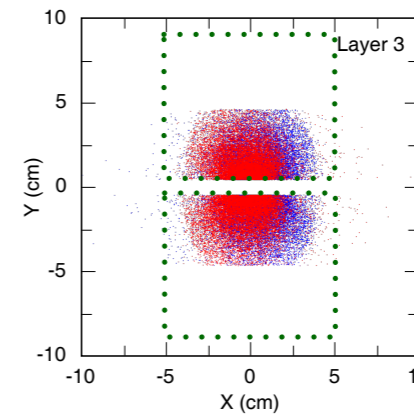
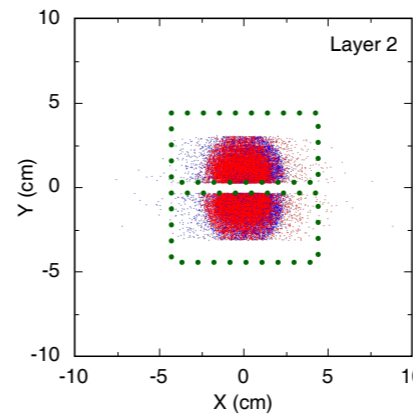
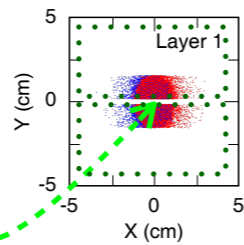
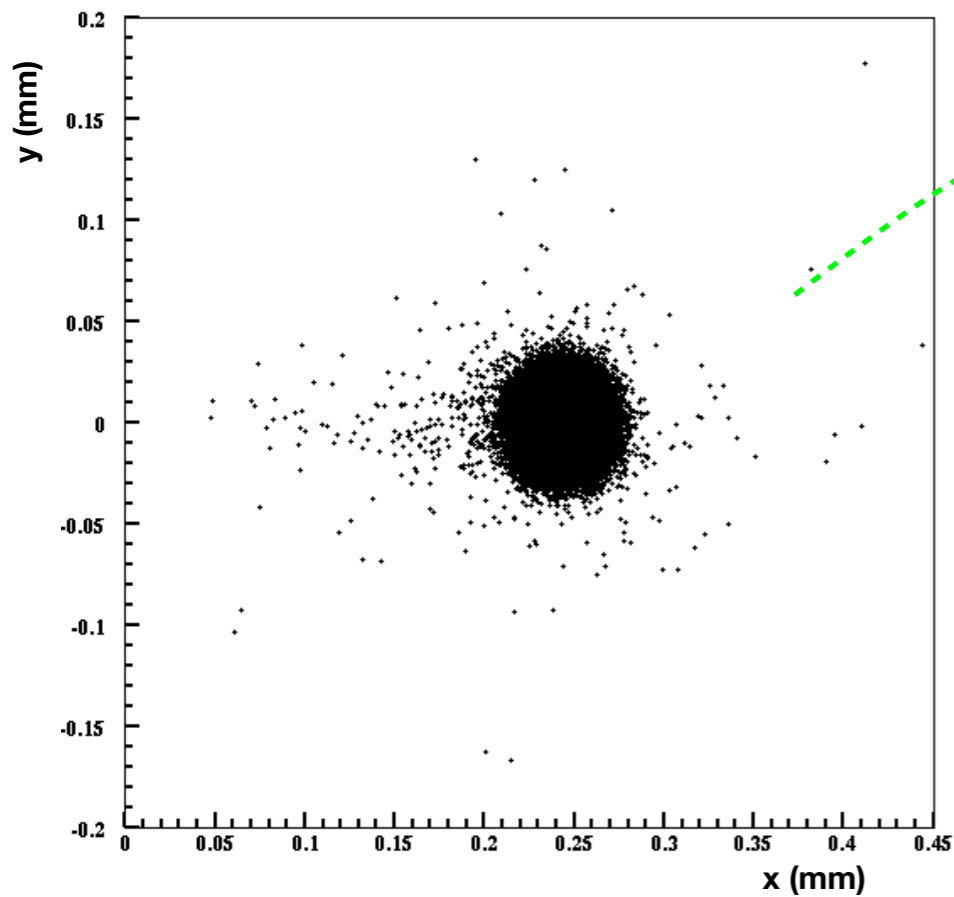




# Dead Zone and Acceptance

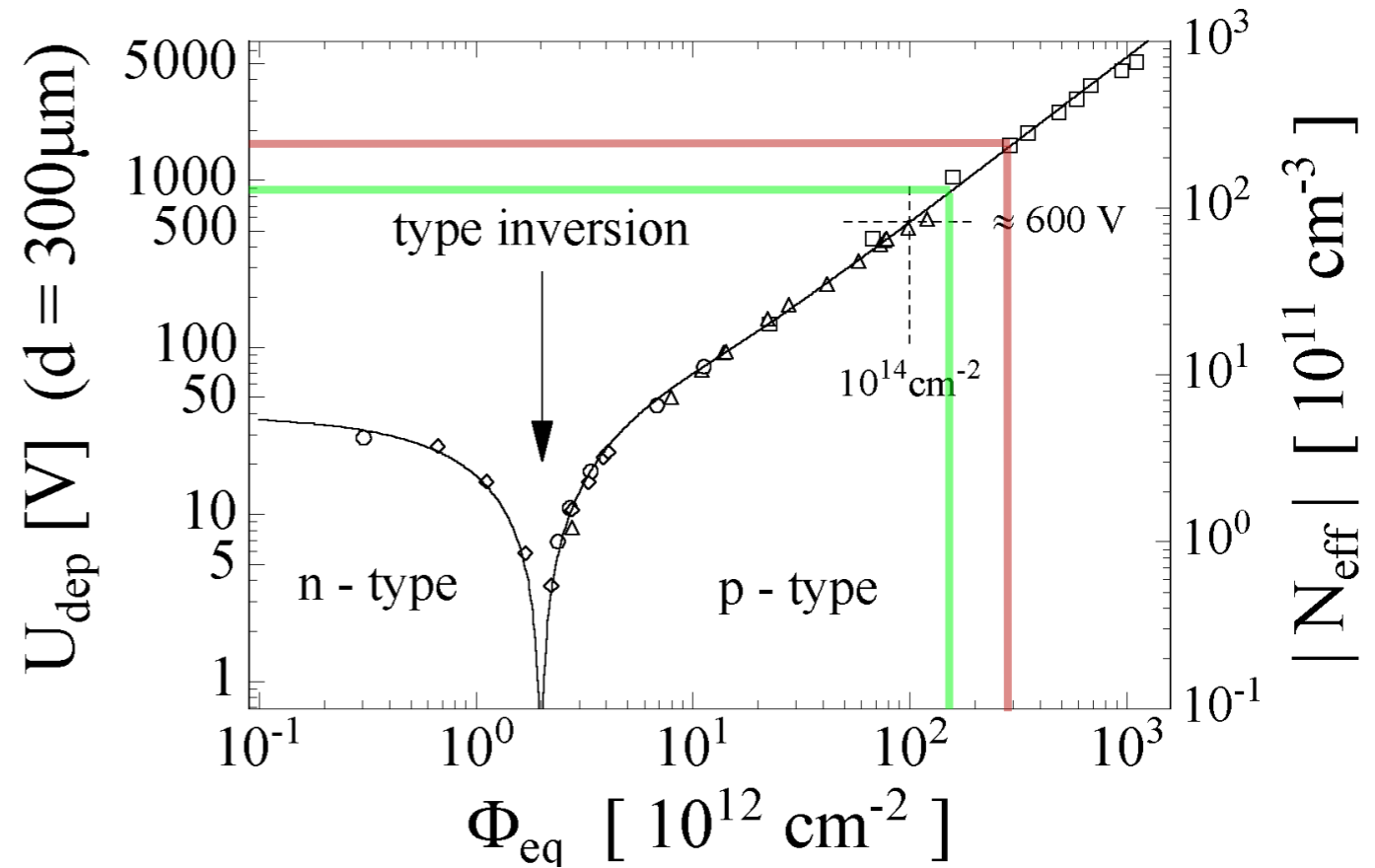
Hits from tracks within acceptance;  
 $E_{\text{beam}}=5.5 \text{ GeV}$   $m_{A'} = 300 \text{ MeV}/c^2$

75 ns of beam at Layer 1



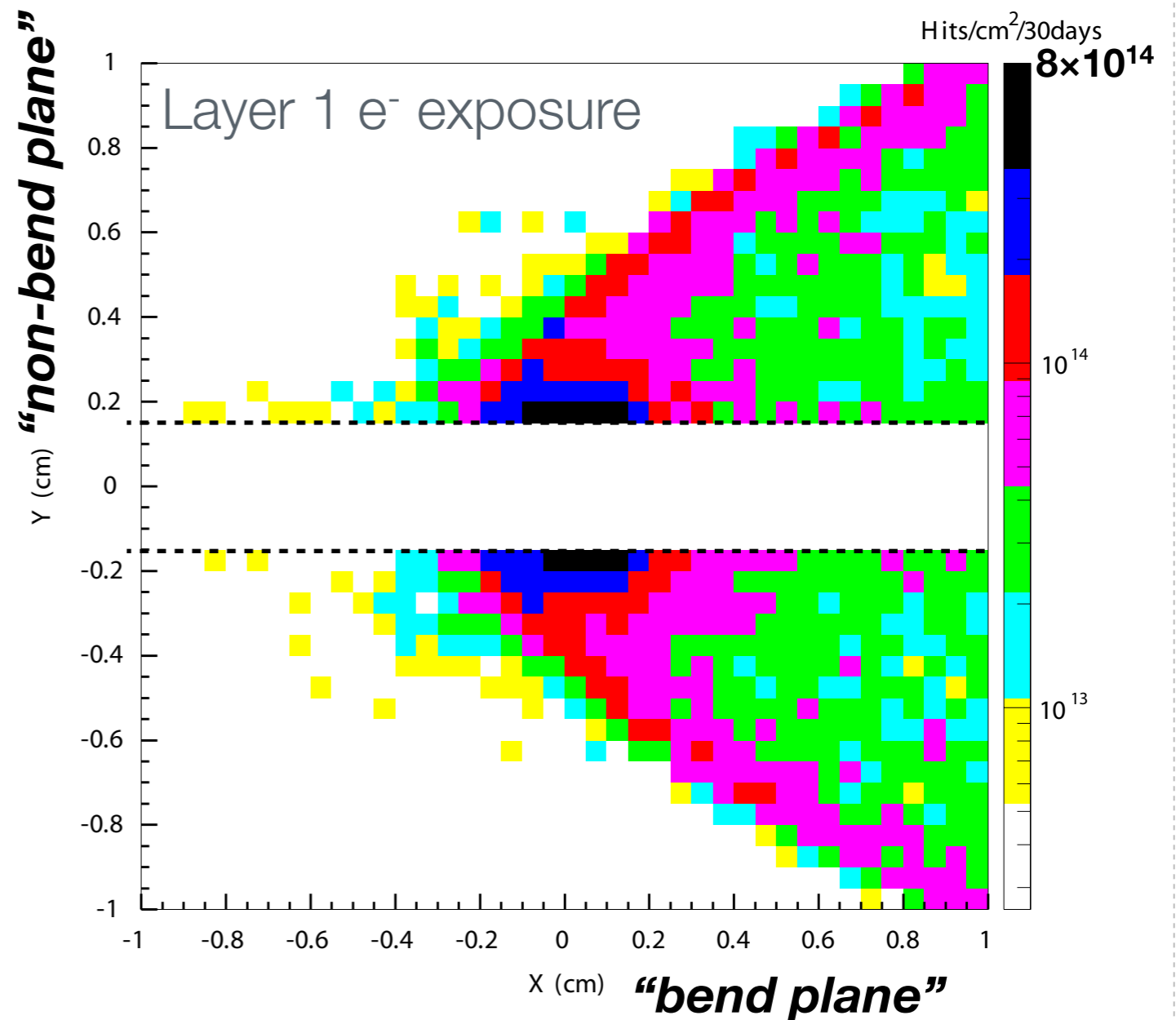
# Dead Zone: Radiation Limit

- At  $V_{\text{bias}} = 1000\text{V}$ , sensors fully depleted up to  $\Phi_{\text{eq}} > 1.4 \times 10^{14} \text{ cm}^{-2}$  (1 MeV neutron equivalent dose)
- After that, a “soft landing,” with lost signal degrading timing and resolution for  $\Phi_{\text{eq}} > 2.5 \times 10^{14} \text{ cm}^{-2}$
- Electron damage is  $\sim 1/30$  that of 1MeV neutrons: full depletion up to  $\sim 4 \times 10^{15} \text{ e}^-/\text{cm}^2$



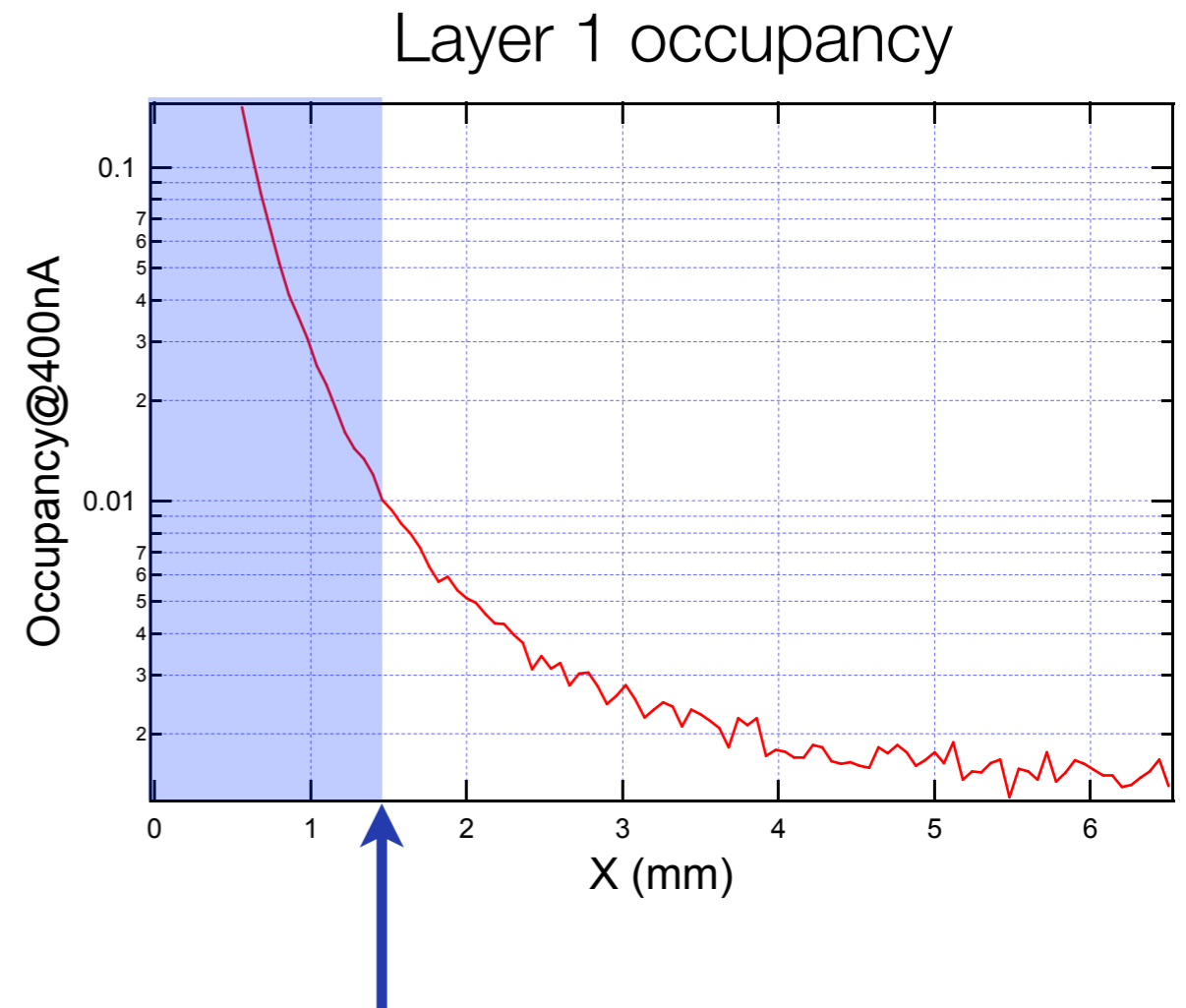
# Dead Zone: Radiation Limit

- Want entire detector to remain fully depleted for 3 months  
 $\Rightarrow \sim 1.4 \times 10^{15} \text{ e}^-/\text{cm}^2 / \text{month}$
- In first layer, conservative choice of dead zone is  $y < \pm 1.5\text{mm}$
- In deeper layers, slightly more solid angle can be covered



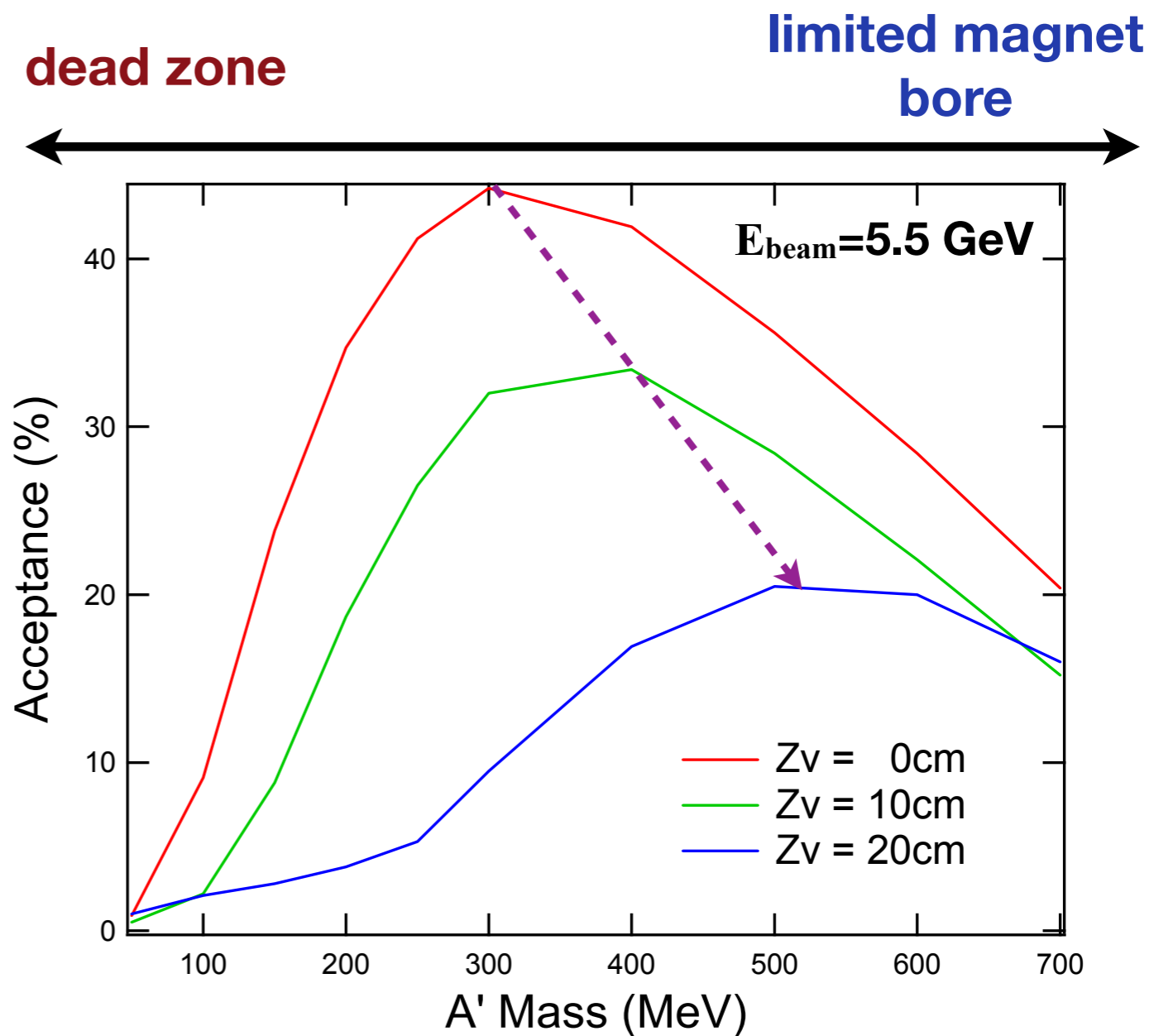
# Dead Zone: Occupancy Limits

- ❏ For pattern recognition, want occupancy within our time resolution window of  $<1\%$
- ❏  $\Rightarrow$  L1 dead zone  $y < \pm 1.4$  mm.
- ❏ Results in L1 unanimous.
- ❏ Since  $z_{L1} = 10\text{cm}$ , implies 15 mrad dead zone for prompt decays. This configuration used for simulation studies and reach calculations.



# Acceptance

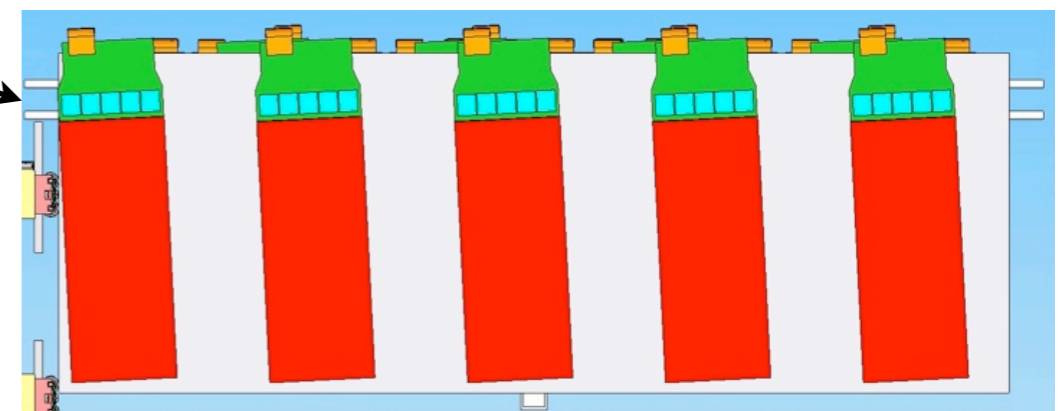
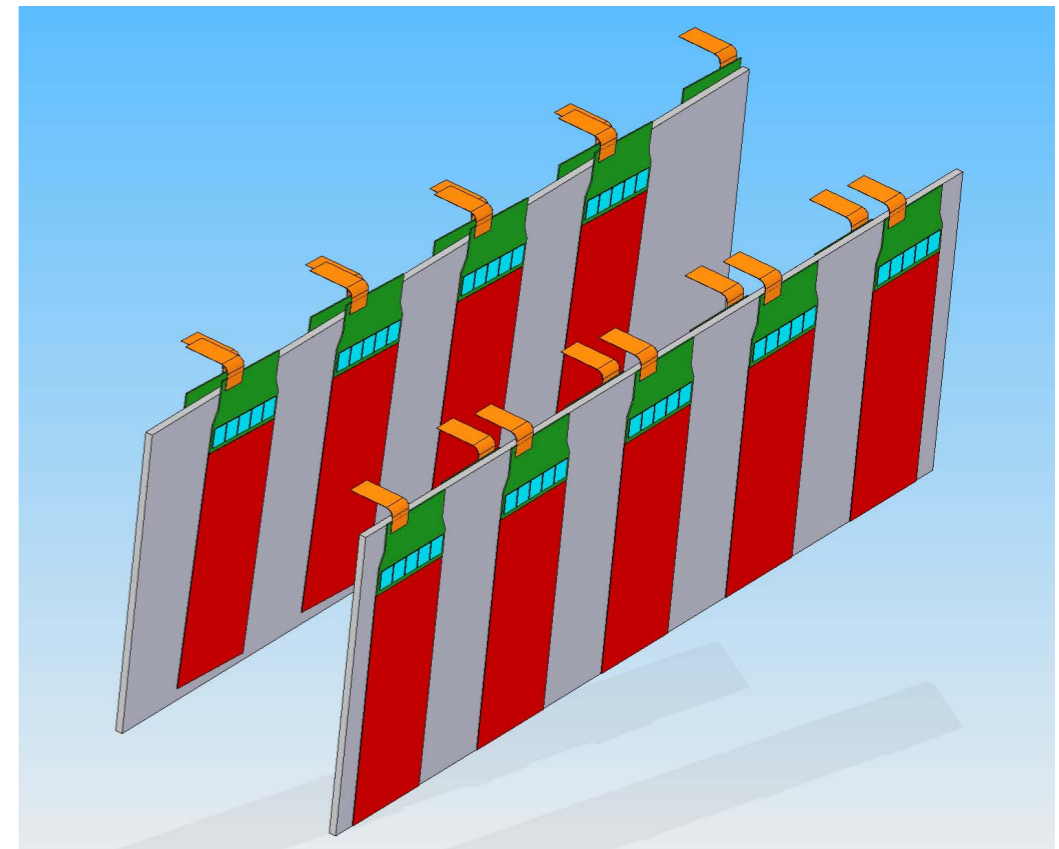
- At smaller masses, dead-zone limits acceptance
- At larger masses, losses due to limited coverage in layers 5 and 6 become important.
- Solid angle of dead zone increases with increasing z-vertex position
- May be possible to decrease dead zone in deeper layers to combat this if we can vertex cleanly without Layer 1



# Support: Sensor Modules

## Simple, familiar construction:

- ❏ silicon for each view on alternating sides of carbon-fiber-skinned, rohacell-foam sheet: each “layer” a stereo pair of modules on either side of dead zone.
- ❏ Voids in supports reduce material
- ❏ cooling tubes only under hybrids, water-glycol at  $-5^{\circ}\text{C}$ .
- ❏ passivated pyrolytic graphite sheet under sensors isolates HV and increases lateral thermal conductivity





# Material Budget

per measurement plane


 ~1.0%  $X_0$  / layer, including overlap regions

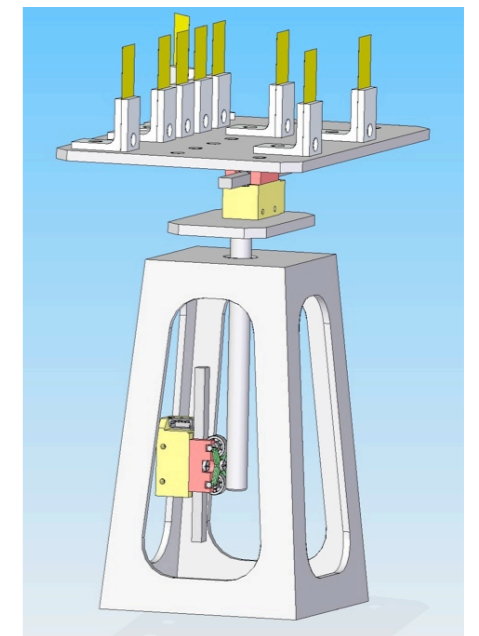
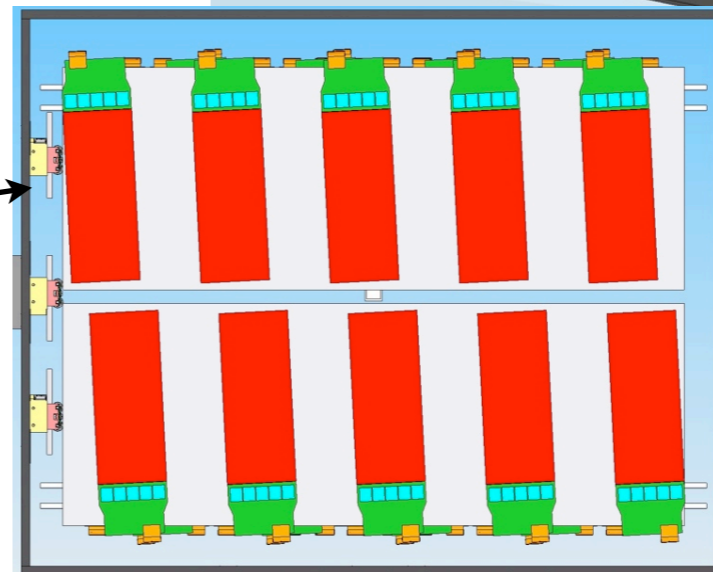
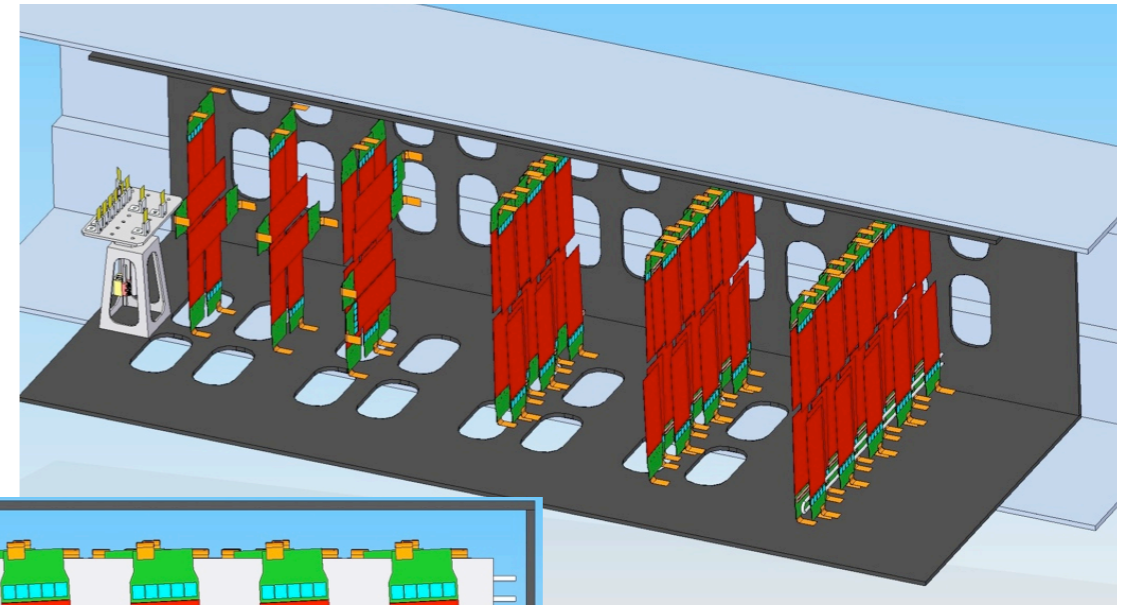

 dominated by silicon itself

	Radiation Length (mm)	Thickness (mm)	Coverage/ Unit Acceptance	Scattering Material (% $X_0$ )
<b>Silicon</b>	<b>93.6</b>	<b>0.320</b>	<b>1.2</b>	<b>0.410</b>
Rohacell Foam	13800	3.0	0.5	0.011
Carbon Fiber	242	0.150	0.5	0.031
PGS Passivation	256	0.101	1.25	0.049
Epoxy	290	0.050	0.5	0.009
Total	-	-	-	<b>0.510</b>



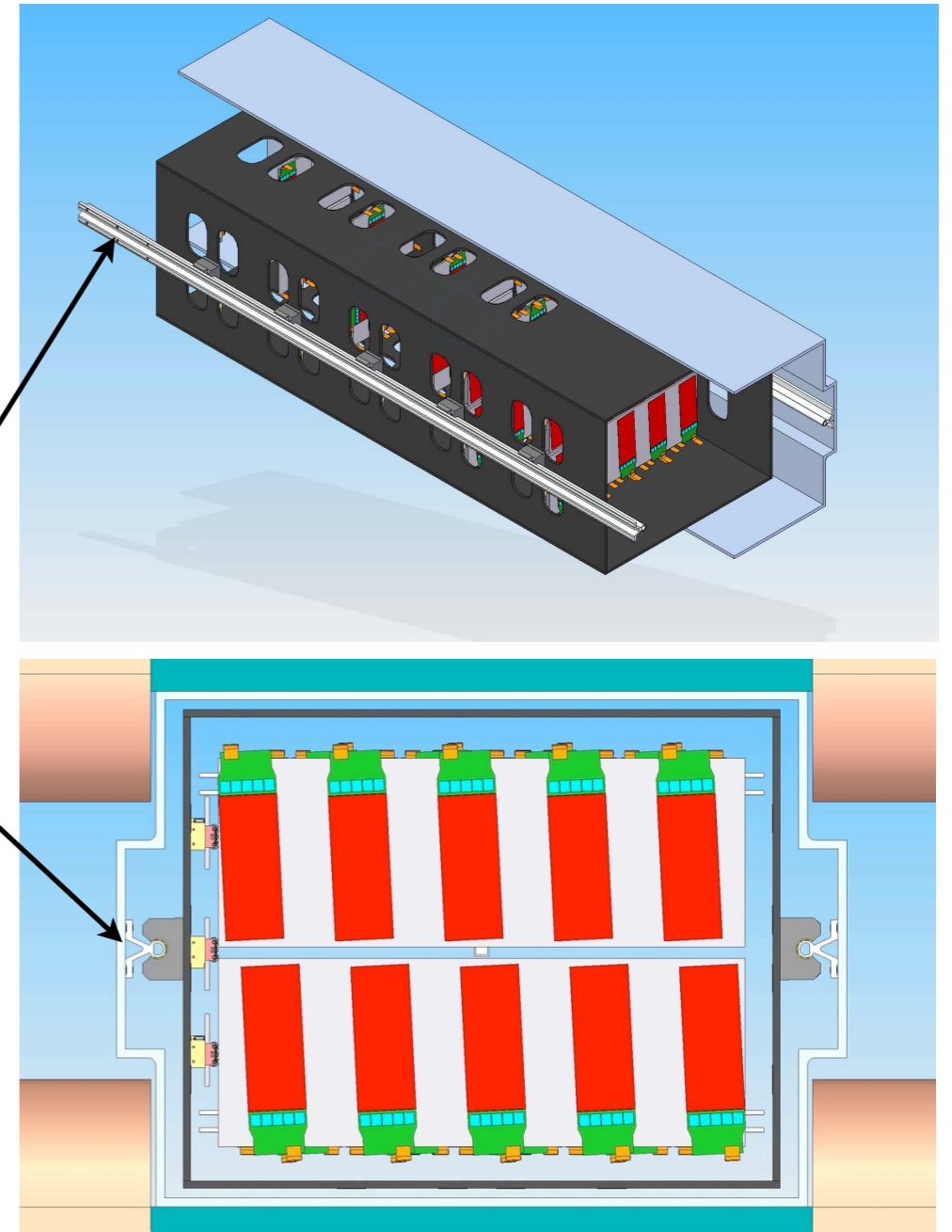
# Support: Support Box

- ❖ similar CF/rohacell composite panels
- ❖ extension cables and cooling lines from hybrids and modules to patch panel on vacuum chamber pre-installed on support box
- ❖ Module mounts include a pair of piezo motors: allow retraction during uncertain beam conditions
- ❖ Supports target stand, including similar motion control system for target selection: nominal target is 0.25%  $X_0$  tungsten.



# Support: Vacuum Chamber

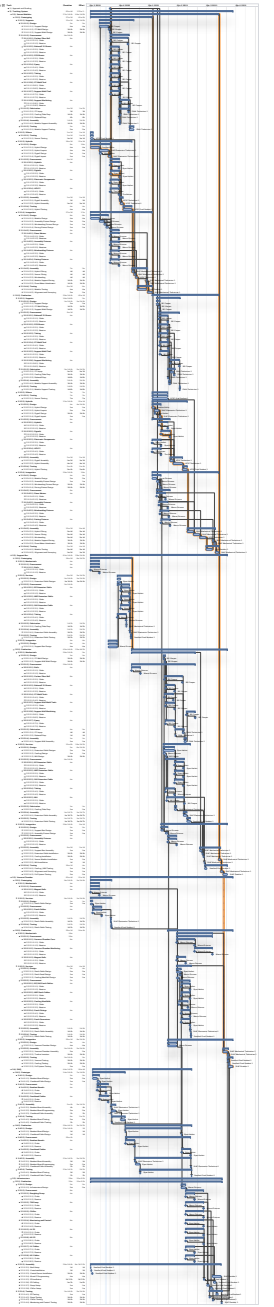
- ❏ vacuum chamber permanently captured inside magnet bore
- ❏ patch panel for cooling and cable connections at front face.
- ❏ linear rail system with carriages on support box for insertion and extraction of tracker
- ❏ Custom multi-layer insulation (MLI) blanket eliminates radiative heating:  $\sim 5\text{W}/\text{module}$ .
- ❏ Ensuring negligible heat load on silicon necessitates vacuum of  $\sim 10^{-4}$  Torr.



# “I’ll Take One To Go, Please...”

Need new glasses??

- ❏ OK... it’s not a pizza, but it’s also not CMS!
- ❏ My own context: similar in scale/scope to CDF Layer 00: channel count, number of sensors/hybrids, budget and some unusual requirements, but less aggressive.
- ❏ silicon already in hand.
- ❏ no components/techniques need R&D.
- ❏ Believe it can be completed in a year.



# “You and What Army?”

🍯 **SLAC:** Tim Nelson, Marco Oriunno, Gunther Haller, Chris Kenney, ...

🍯 **UCSC:** Alex Grillo, Ned Spencer, ...

🍯 **FNAL:** Marcel Demarteau, Bill Cooper, ...

🍯 CDF RunII, D0 RunII and Run2b, CMS, ATLAS, CLEO-II, Babar, ILC, SDC...  
many decades of experience in the group!

🍯 Includes leading expertise in semiconductor devices, readout/DAQ, carbon fiber supports, cryogenics/vacuum: *everything* that is needed here.

🍯 Group consensus that schedule and budget are reasonable.

# Summary

- ❖ A relatively small and simple tracker is all we need (see Matt's talk after lunch for review of how the system performs.)
- ❖ The most expensive and complicated components, sensors and readout ASICs, are well-developed and readily available free or at reasonable cost.
- ❖ Some unusual requirements (operation in vacuum, movable planes) will require careful attention.
- ❖ Time pressure is the biggest challenge. Important to get started as soon as possible and avoid unnecessary distractions and development by keeping things simple wherever possible.





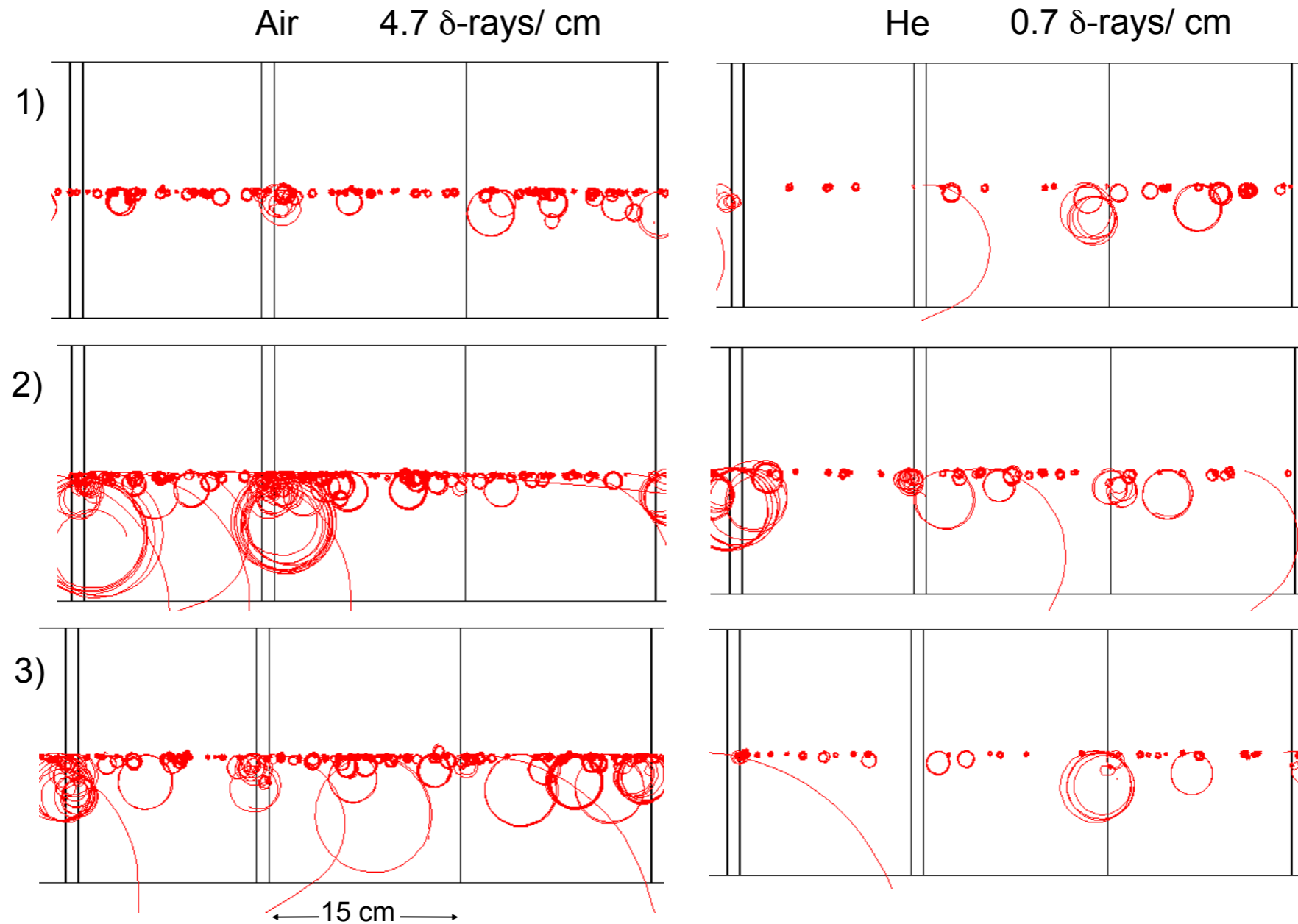
# Backup Slides





# Why Vacuum?

$\delta$ -ray background in 25 ns



# Upgrade?

## **Thin silicon in Layers 1 and 2?**

- ❏ Reduces material budget by 0.15%  $X_0$  / plane: 30% of total.
- ❏ S/N still ~22: timing resolution degrades by only ~10%.
- ❏ Cost: \$37.5k for silicon per copy
- ❏ Should be possible to use same hybrids, partially populated, with a pitch adapter
- ❏ Additional risk for parts not in hand. Risk in working with Micron, but minimal for such a small production of single-sided sensors.